



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukio MIYAIRI et al.

Group Art Unit: 1795

Application No.: 10/561,841

Examiner: K. MAYEKAR

Filed: December 22, 2005

Docket No.: 126400

For: PLASMA GENERATING ELECTRODE AND PLASMA REACTOR

SUBMISSION OF REFERENCES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the following references be placed in the Patent Office file regarding the above-identified application.

- ☒ 1. An English language Abstract of one or more non-English language reference is attached. See References 1 & 2.
- ☒ 2. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1 & 2.

Respectfully submitted,

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Date: April 23, 2010

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